

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )

Shunpei YAMAZAKI et al. )

Serial No. 09/535,015 )

Filed: March 24, 2000 )

For: METHOD OF MANUFACTURING )

A SEMICONDUCTOR DEVICE )

) Group Art Unit: 2811

) Examiner: S. Crane

#10  
Election  
FJONES  
8-2-02

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with  
The United States Postal Service with sufficient postage as First  
Class Mail in an envelope addressed to: Commissioner for Patents,  
Washington, D.C. 20231, on 7/18/02

RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner for Patents


Washington, D.C. 20231

Sir:

In response to the election requirement in the Office Action of June 18, 2002, Applicants hereby elect with traverse species I, a semiconductor film containing hydrogen or halogen. Claims 2-14 and 21 are readable thereon. Furthermore, Applicants note that independent claim 29 recites a semiconductor film containing a hydrogen and independent claim 35 recites a semiconductor film containing a halogen. Thus, it is believed that claims 29-43 should also be examined with species I.

Examination on the merits is requested.

Respectfully submitted,

  
Eric J. Robinson  
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.  
PMB 955  
21010 Southbank Street  
Potomac Falls, Virginia 20165  
(571) 434-6789

RECEIVED  
JUL 24 2002  
TECHNOLOGY CENTER 2808